UTILITY
PATENT APPLICATION
TRANSMITTAL

206342US2 Attorney Docket No.

First Inventor or Application Identifier

WA, et al.

(Only for new nonprovisional applications under 37 CFR 1-53(b)

WORKTABLE DEVICE AND PLASMA PROCESSING APPARATUS FOR SEMICONDUCTOR PROCESS

Toshifumi N

jc8	60	U.S	. PTO

Assignee Name Assignee Address:

04/24/01 APPLICATION ELEMENTS	
See MPEP chapter 600 concerning utility patent application con	tents

Assistant Commissioner for Patents ADDRESS TO: Box Patent Application

Washington, DC 20231

Fee Transmittal Form (e.g. PTO/SB/17)

(Submit an original and a duplicate for fee processing)

Total Sheets 17 Specification

Total Sheets 3. Drawing(s) (35 U.S.C. 113)

Formals

Total Pages □ Oath or Declaration a.

 □ Newly executed (original or copy)

Copy from a prior application (37 C.F.R, §1.63(d)) b. □ (for continuation / divisional w/ box 17 completed)

DELETION OF INVENTOR(S) Signed statement attached deleting inventor(s) named in the prior application, see 37 C.F.R. §1.63(d)(2) and

CD-ROM or CD-R in duplicate, large table or Computer Program (Appendix)

6.

Nucleotide and/or Amino Acid Sequence Submission (if applicable, all necessary)

a.

Computer Readable Form (CRF)

b. Specification or Sequence Listing on:

i. □ CD-ROM or CD-R (2 copies); or

ii.

Paper

c.

Statements verifying identity of above copies

ACCOMPANYING APPLICATION PARTS

7.

Assignment Papers (cover sheet & document(s))

Application Data Sheet. See 37 CFR 1.76

37 C.F.R. §3.73(b) Statement (when there is an assignee) Power of Attorney

10. ☐ English Translation Document (if applicable)

Copies of IDS Citations (1) Information Disclosure Statement (IDS)/PTO-1449

12. D Preliminary Amendment

White Advance Serial No. Postcard

Certified Copy of Priority Document(s) (if foreign priority is claimed) 14.

Applicant claims small entity status. 15. \square

Notice of Priority, List of Inventors' Names and Addresses, Statement Re Filing in 16. ■ Other:

Foreign Language

17. If a CONTINUING APPLICATION, check appropriate box, and supply the requisite information below:

Continuation

□ Divisiona!

☐ Continuation-in-part (CIP)

of prior application no.:

Prior application information:

Examiner:

Group Art Unit:

For CONTINUATION OR DIVISIONAL APPS only: The entire disclosure of the prior application, from which an oath or declaration is supplied under Box 4b, is considered a part of the accompanying continuation or divisional application and is hereby incorporated by reference. The incorporation can only be relied upon when a portion has been inadvertently omitted from the submitted application parts.

18. Amend the specification by inserting before the first line the sentence:

Continuation

□ This application is a of application Serial No. Division

Filed on

□ Continuation-in-part (CIP)

Which was published in English

Which was not published in English

☐ This application claims priority of provisional application Serial No.

Filed

19. CORRESPONDENCE ADDRESS



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Name:	Marvin J. Spivak	Registration No.:	24,913
Signature:	6mm Kullan	Date:	4/24/01
Name:	C. Irvin McClelland	Registration No.:	

Docket No.

206342US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Toshifumi NAGAIWA, et al.

SERIAL NO. NEW APPLICATION

FILING DATE: HEREWITH

FOR: WORKTABLE DEVICE AND PLASMA PROCESSING APPARATUS FOR SEMICONDUCTOR PROCESS

STATEMENT RE FILING IN FOREIGN LANGUAGE

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

It is hereby stated that the subject application is being filed in a foreign language, in accordance with the provisions of 37 CFR 1.52(d).

An accurate English translation, and a suitable amendment placing the application and claims thereof into proper U.S. format if needed, will be filed in due course.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Marvin J. Spivak

Registration No. 24,913

C. Irvin McClelland Registration Number 21,124

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Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 10/98) Docket No.

206342US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Toshifumi NAGAIWA, et al.

SERIAL NO:

New Application

FOR:

FILING DATE: Herewith

WORKTABLE DEVICE AND PLASMA PROCESSING APPARATUS FOR SEMICONDUCTOR PROCESS

FEE TRANSMITTAL

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS
TOTAL CLAIMS	20 - 20 =	0	× \$18 =	\$0.00
INDEPENDENT CLAIMS	2 - 3 =	0	× \$80 =	\$0.00
□ MULTIPLE DEPENDE	MULTIPLE DEPENDENT CLAIMS (If applicable) + \$270 =		+ \$270 =	\$0.00
■ LATE FILING OF DECLARATION + \$130 =			+ \$130 =	\$130.00
BASIC FEE				\$710.00
	\$840.00			
□ REDUCTION BY 50% FOR FILING BY SMALL ENTITY				\$0.00
■ FILING IN NON-ENGLISH LANGUAGE + \$130 =			\$130.00	
RECORDATION OF ASSIGNMENT + \$40 =		\$0.00		
			TOTAL	\$970.00

Please charge Deposit Account No. 15-0030 in the amount of

A duplicate copy of this sheet is enclosed.

A check in the amount of

\$970.00

to cover the filing fee is enclosed.

The Commissioner is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Date:

4/24/01

Marvin J. Spivak

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